



IPW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto HIRANO et al.

Group Art Unit: 1792

Application No.: 10/570,156

Examiner: N. FORD

Filed: March 27, 2006

Docket No.: 127194

For: SUBSTRATE TREATMENT EQUIPMENT AND MANUFACTURING METHOD OF  
SUBSTRATE

**RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 18, 2008 Restriction Requirement, please consider the  
following:

**Amendments to the Claims** as reflected in the listing of the claims; and

**Remarks.**